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AF  
Docket No. 8733.913.00  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Sang-Hyun KIM

Customer No. 30827

Application No. 10/663,805

Confirmation No. 3765

Filed: September 17, 2003

Art Unit: 1763

For: FABRICATION METHOD OF  
POLYCRYSTALLINE SILICON TFT

Examiner: George A. Goudreau

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

In response to the final Office Action dated March 17, 2006, please amend the patent application identified above as follows:

**INTRODUCTORY COMMENTS**

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.